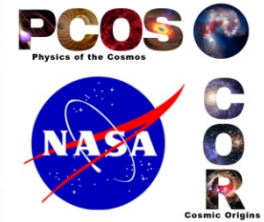


Ultraviolet Coatings, Materials and Processes for Advanced Telescope Optics

PI: K. Balasubramanian/JPL



Description and Objectives:

- “Development of UV coatings with high reflectivity (>90-95%), high uniformity (<1-0.1%), and wide bandpasses (~100 nm to 300-1000 nm)” is a major technical challenge as much as it is a key requirement for cosmic origins program and for exoplanet exploration program. This project aims to address this key challenge and develop feasible technical solutions.

Key Challenge/Innovation:

- Materials and process technology are the main challenges. Improvements in existing technology base and significant innovations in coating technology such as Atomic Layer Deposition will be developed.

Approach:

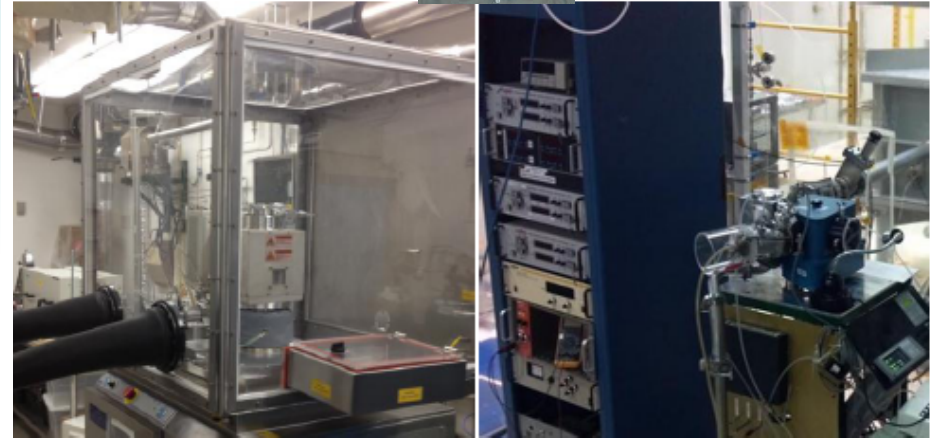
- A set of experimental data will now be developed with MgF_2 , AlF_3 and LiF protected Al mirrors in the wavelength range 100 to 1000 nm for a comprehensive base of measured data to enable full scale developments with chosen materials and processes.
- Enhanced coating processes including Atomic Layer Deposition (ALD) will be studied; Characterization and measurement techniques will be improved.

Key Collaborators:

- Stuart Shaklan (JPL), Nasrat Raouf (JPL), Shouleh Nikzad (JPL), Frank Greer (JPL), Paul Scowen (ASU), James Green (Univ of Colo)

Development Period:

- Jan 2013 – Dec 2015



ALD chamber at JPL

Deep UV Test station
at U of Colorado

Accomplishments and Next Milestones:

- A coating chamber has been upgraded with sources, temperature controllers and other monitors to produce coatings of various fluorides; measurement tools are also established now at JPL and U of Colo.
- Preliminary coatings with various fluorides will be produced and characterized during Aug-Dec 2013.
- Enhancements to conventional coating techniques will be developed; ALD coating process tools and process will be established at JPL (2014)
- ALD and other enhanced coating processes for protected and enhanced aluminum mirror coatings will be developed and improved (2015)
- Test mirror coupons representing a meter-class mirror to be produced and characterized (2015)

Application:

- The technology developed through this project will enable future astrophysics and exoplanet missions that aim to capture key spectral features from far UV to near infrared.

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